

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Shigeru Terashima	~	Confirmation No.:	8857
Application No.:	10/785,252	~		
Filed:	February 23, 2004	~	Examiner:	Rutledge, Della J.
For:	EXPOSURE APPARATUS AND EXPOSURE METHOD	~	Art Unit:	2851

Mail Stop Amendments  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION/AMENDMENT**

Madam:

In response to the Office Action mailed March 16, 2006, reconsideration of this action and allowance of the claims of the present application are respectfully requested in view of the following remarks:

***Remarks/Arguments*** begin on page 2 of this paper.